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Name of applicant, assignee or
Registered Representative

W. A. Webb
Signature

11-16-01

Date of Signature

Our Case No. 10519/57

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Herner et al.)
Serial No.: 09/928,975)
Filing Date: August 13, 2001)
For: LOW RESISTIVITY TITANIUM SILICIDE)
ON HEAVILY DOPED)
SEMICONDUCTOR)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Commissioner:

Applicant has enclosed copies of documents A1-A4 as listed on the attached Form PTO 1449. These documents are discussed in the opening paragraphs of this Application, and Applicant requests that they be reviewed and made of record.

Respectfully submitted,

W. A. Webb
William A. Webb
Registration No. 28,277
Attorney for Applicant

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